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Bib Data Sheet

**CONFIRMATION NO. 7998** 

| SERIAL NUMBEI<br>10/615,051   | FILING DATE<br>07/07/2003<br>RULE                              |  |  | CLASS<br>438 |  | GROUP ART UNIT<br>2823  |                      | ATTORNEY DOCKET<br>NO.<br>MI22-2308 |                       |  |
|---|--|--|--|--------------|--|---|----------------------|-------------------------------------|-----------------------|--|
| Brian A. Vaartstra, Nampa, ID;  *** CONTINUING DATA **********************************  |  |  |  |              |  |   |                      |                                     |                       |  |
| Foreign Priority claimed  yes ono  35 USC 119 (a-d) conditions met yes ono Met after Allowance  Verified and Acknowledged Examiner's Signature  STATE OR  COUNTRY |  |  |  |              |  | EETS<br>AWING<br>3  | TOTAL CLAIMS 58' 4-2 |                                     | INDEPENDENT<br>CLAIMS |  |
| ADDRESS 021567 WELLS ST. JOHN P.S. 601 W. FIRST AVENUE, SUITE 1300 SPOKANE, WA 99201  |  |  |  |              |  |   |                      |                                     |                       |  |
| TITLE  Methods of forming a phosphorus doped silicon dioxide-comprising layer   |  |  |  |              |  |   |                      |                                     |                       |  |
| N   | No to charge/credit DEPOSIT ACCOUNT  ECEIVED No for following: |  |  |              |  | All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue)  Other  Credit |                      |                                     |                       |  |